

10/540992

JC17 Rec'd PCT/PTO 28 JUN 2005

Attorney Docket No. 061063-0316598  
Client Reference: OSP-18418

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: JEA GUN PARK, UN GYU PAIK, JIN HYUNG PARK, and TAKEO KATO

Application No.:

Confirmation

No:

Filed: June 28, 2005

Group No.:

Examiner

For: CHEMICAL-MECHANICAL-POLISHING SLURRY COMPOSITION, METHOD FOR PLANARIZING SURFACE OF SEMICONDUCTOR DEVICE USING THE SAME, AND METHOD FOR CONTROLLING SELECTION RATIO OF SLURRY COMPOSITION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**APPLICATION DATA SHEET**  
37 C.F.R. § 1.76

**BIBLIOGRAPHIC DATA**

**1. Applicant information**

First applicant: JEA GUN PARK  
Citizenship: REPUBLIC OF KOREA  
Residence: Seongnam-city, Kyungki-do, Republic of Korea

Second applicant: UN GYU PAIK  
Citizenship: REPUBLIC OF KOREA  
Residence: Kangnam-gu, Seoul, Republic of Korea

Third applicant: JIN HYUNG PARK  
Citizenship: REPUBLIC OF KOREA  
Residence: Ulsan-city, Republic of Korea

Fourth applicant: TAKEO KATO  
Citizenship: JAPAN  
Residence: Seongdong-gu, Seoul, Republic of Korea

**2. Correspondence information**

Correspondence for this application should be addressed as follows:

Customer No.: 00909

**3. Application information**

Title of Invention: CHEMICAL-MECHANICAL-POLISHING SLURRY COMPOSITION,  
METHOD FOR PLANARIZING SURFACE OF SEMICONDUCTOR DEVICE USING THE  
SAME, AND METHOD FOR CONTROLLING SELECTION RATIO OF SLURRY  
COMPOSITION

Docket number assigned to this application: 061063-0316598

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 10

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

#### **4. Representative information**

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

#### **5. Domestic Priority information**

Domestic priority for this application is claimed as follows:

35 U.S.C. § 365(c):

Application No.: PCT/JP03/16813

Filed: December 25, 2003

Status: Pending

Relationship: Parent

#### **6. Foreign priority information**

Foreign priority is claimed for this application as follows:

Country: REPUBLIC OF KOREA

Application No.: 10-2002-0087934

Filing Date: December 31, 2002

Status: Pending

#### **7. Assignee information**

The assignee(s) of this application is/are:

Sumitomo Mitsubishi Silicon Corporation

2-1, Shibaura 1-chome, Minato-ku

Tokyo,

JAPAN

Extent of interest of assignee in application: undivided interest

10/540992

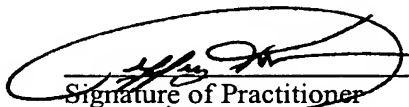
JC17 Rec'd PCT/PTO 28 JUN 2005

Hanyang Hak Won Co., Ltd.  
17, Haengdang 1-dong, Seongdong-gu  
Seoul,  
REPUBLIC OF KOREA

Extent of interest of assignee in application: undivided interest

Date: June 28, 2005

PILLSBURY WINTHROP SHAW PITTMAN  
LLP  
P.O. Box 10500  
McLean, VA 22102  
Customer No. 00909

  
Signature of Practitioner  
Jeffrey D. Karceski  
Registration No. 35914  
(703) 905.2110